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DATE MAILED: 04/15/2004

| APPLICATION NO.         | FILING DATE   | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO.              | CONFIRMATION NO. |
|-------------------------|---------------|----------------------|----------------------------------|------------------|
| 10/084,284              | 02/26/2002    | Hyeon-Su An          | 8028-16 7098<br>(SPX200110019US) |                  |
| 759                     | 90 04/15/2004 | 04/15/2004           |                                  | INER             |
| Frank Chau              |               |                      | LUU, THANH X                     |                  |
| F.CHAU & ASS            | SOCIATES, LLP |                      |                                  |                  |
| Suite 501               |               |                      | ART UNIT                         | PAPER NUMBER     |
| 1900 Hempstead Turnpike |               |                      | 2878                             |                  |

Please find below and/or attached an Office communication concerning this application or proceeding.

|  |  | A   |  | <del></del>   |  |  |  |
|--|--|---|--|---|--|--|--|
| Office Action Summary  |  | Application N   | D.   /   | Applicant(s) '  |  |  |  |
|  |  | 10/084,284  |  | AN, HYEON-SU  |  |  |  |
|  |  | Examiner  |  | Art Unit  |  |  |  |
|  |  | Thanh X Luu   | 1  | 2878  |  |  |  |
| Period fo  | The MAILING DATE of this communication ap<br>or Reply  | pears on the cov  | er sheet with the co   | respondence address   |  |  |  |
| THE - Exte after - If the - If NC - Failt Any  | ORTENED STATUTORY PERIOD FOR REPL MAILING DATE OF THIS COMMUNICATION. nsions of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. e period for reply specified above is less than thirty (30) days, a repi or period for reply is specified above, the maximum statutory period are to reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).  | 136(a). In no event, ho<br>ly within the statutory n<br>will apply and will expir<br>e, cause the application | wever, may a reply be timel<br>ninimum of thirty (30) days v<br>e SIX (6) MONTHS from the<br>to become ABANDONED | y filed vill be considered timely. e mailing date of this communication. (35 U.S.C. § 133). |  |  |  |
| Status   |  |   |  |   |  |  |  |
| 1)⊠  | Responsive to communication(s) filed on 20 F   | ebruary 2004.   |  |   |  |  |  |
| · · · · · ·  | 'his action is <b>FINAL</b> . 2b)⊠ This action is non-final.   |   |  |   |  |  |  |
| 3)□  | Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.  |   |  |   |  |  |  |
| Disposit   | ion of Claims  |   |  |   |  |  |  |
| 5)□<br>6)⊠<br>7)□  | Claim(s) 1-8 and 10 is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.  Claim(s) is/are allowed.  Claim(s) 1-8 and 10 is/are rejected.  Claim(s) is/are objected to.  Claim(s) are subject to restriction and/or election requirement.   |   |  |   |  |  |  |
| Applicat   | ion Papers   |   |  |   |  |  |  |
| 10)  | The specification is objected to by the Examine The drawing(s) filed on is/are: a) acc Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Examine The specification is objected to be specification. | cepted or b) or   | d in abeyance. See 3<br>he drawing(s) is objed   | 37 CFR 1.85(a).<br>cted to. See 37 CFR 1.121(d).  |  |  |  |
| Priority (   | ınder 35 U.S.C. § 119  |   |  |   |  |  |  |
| 12)[_<br>a)  | Acknowledgment is made of a claim for foreign All b) Some * c) None of:  1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureasee the attached detailed Office action for a list  | ts have been red<br>ts have been red<br>prity documents l<br>uu (PCT Rule 17                                  | ceived.<br>ceived in Application<br>nave been received<br>2(a)).   | n No<br>in this National Stage  |  |  |  |
| Attachmen  | t(s)<br>se of References Cited (PTO-892)   | 4) F  | ] Interview Summary (F   | PTO-413)  |  |  |  |
| 2)  Notice  No | re of Draftsperson's Patent Drawing Review (PTO-948)  mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  or No(s)/Mail Date   | ,   | _ Paper No(s)/Mail Date  |   |  |  |  |

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#### **DETAILED ACTION**

This Office Action is in response to amendments and remarks filed February 20, 2004. Claims 1-8 and 10 are currently pending.

## Claim Rejections - 35 USC § 112

- 1. The following is a quotation of the second paragraph of 35 U.S.C. 112:
  - The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 2. Claim 4 is rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

Regarding claim 4, "the main processor" lacks proper antecedent basis.

## Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 4. Claims 7, 8 and 10 are rejected under 35 U.S.C. 102(b) as being anticipated by Tomoyoshi et al. (Japanese Patent 10-318933, published December 4, 1998).

Regarding claims 7, 8 and 10, Tomoyoshi et al. disclose (see Figs. 1 and 3) a multi-functional wafer aligner and method, comprising: a rotatable chuck (23), adapted to receive a semiconductor wafer (W); a wafer transfer unit (not shown), adapted to position the wafer upon the rotatable chuck; a sensor body (at 30), comprising: a position compensator (30); a luminous source (31, 51); and a wafer damage detector

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comprising an array of damage-detecting sensors (32a, 32b) to receive light emitted from the luminous source that is reflected off of the edge of the wafer; wherein the sensor body is disposed in relation to the rotatable chuck so as to receive an edge of the wafer within the position compensator. Tomoyoshi further discloses (see Fig. 3) a photodetector (52) disposed upon an opposing side of the luminous source, the photodetector adapted to receive light emitted by the luminous source, wherein the photodetector determines a position of the wafer.

#### Claim Rejections - 35 USC § 103

- 5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 6. Claims 1-6 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tomoyoshi.

Regarding claims 1, 5 and 6, Tomoyoshi discloses (see Figs 1 and 3) a multi-functional wafer aligner, comprising: a multi-functional unit for performing a wafer damage detection; the unit comprising: a wafer rotator (23); an array of luminous emitters (31, 51) for emitting incident rays towards a wafer (W) disposed on the wafer rotator; and an array of damage-detecting sensors (32a, 32b) for receiving the incident rays reflected from the edges of the wafer to detect wafer damage; and a processor (40) for determining positions (with 52) based on a signal. Tomoyoshi also discloses (see Fig. 2) a first area (32a) in the array receives reflected rays when the wafer is not

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damaged and a second area (32b) in the array that receives reflected rays when the wafer is damaged. Tomoyoshi does not specifically disclose a flat zone alignment, wafer centering or an accumulated digital signal. However, it is notoriously well known in the art to center a wafer before rotating and detect a flat zone for alignment purposes. Further, it is well known that digital processors are more robust to noise than analog devices. Thus, it would have been obvious to a person of ordinary skill in the art at the time the invention was made to provide an accumulated digital signal, provide flat zone alignment and center the wafer in the apparatus of Tomoyoshi to provide proper alignment for the wafer and to obtain improved operation through more noise resilient digital signals.

Regarding claims 2 and 3, Tomoyoshi discloses (see Fig. 3) a photo detecting sensor (52) for detecting the position of the wafer as claimed. Tomoyoshi does not specifically disclose an array of photodetectors. However, it is a matter of design choice to provide a plurality of detectors. It would have been obvious to a person of ordinary skill in the art at the time the invention was made to provide an array of photo detecting sensors in the apparatus of Tomoyoshi to provide more precise position signals of the wafer for improved operation.

Regarding claim 4, Tomoyoshi discloses the claimed invention as set forth above. Tomoyoshi does not specifically disclose an alarm. However, it is notoriously well known in the art to create an alarm when a damage condition is present. Thus, it would have been obvious to a person of ordinary skill in the art at the time the invention

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was made to provide an alarm in the apparatus of Tomoyoshi to alert a user of potential damage to a wafer and improve inspection.

## Response to Arguments

7. Applicant's arguments with respect to the claims have been considered but are most in view of the new ground(s) of rejection.

#### Conclusion

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thanh X Luu whose telephone number is (571) 272-2441. The examiner can normally be reached on M-F (6:30-4:00) First Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Porta can be reached on (571) 272-2444. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thanh X Luú Primary Examiner Art Unit 2878